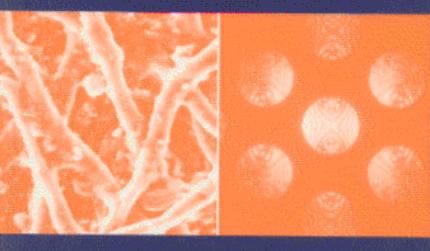
# ELECTRON MICROSCOPY AND ANALYSIS THIRD EDITION

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# Contents

Acroi Prefe		ix xi
Micr	oscopy with light and electrons	1
1.1	Introduction 1	
1.2	Methods of image formation 2	
1.3	Pixels 3	
1.4	The light-optical microscope 4	
1.5	Magnification 7	
1.6	Resolution 8	
1.7	Depth of field and depth of focus 12	
1.8	Aberrations in optical systems 14	
1.9	Electrons versus light 16	
1.10	Questions 19	
Elect	rons and their interaction with the specimen	20
2.1	Introduction 20	
2.2	Electrons 20	
2.3	Generating a beam of electrons 24	
2.4	Deflection of electrons - magnetic lenses 27	
2.5	The scattering of electrons by atoms 29	
2.6	Elastic scattering 30	
2.7	Inelastic scattering 31	
2.8	Secondary effects 34	
2.9	The family of electron microscopes 37	
2.10	Questions 38	

3	Elect	ron diffraction	40
	3.I	The geometry of electron diffraction 41	
	3.2	Diffraction spot patterns 47	
	3.3	Use of the reciprocal lattice in diffraction analysis 51	
	3.4	Other types of diffraction pattern 58	
	3.5	Questions 64	
4	The t	transmission electron microscope	66
	4.1	The instrument 66	
	4.2	Contrast mechanisms 76	
	4.3	High voltage electron microscopy (HVEM) 108	
	4.4	Scanning transmission electron microscopy (STEM) 110	
	4.5	Preparation of specimens for TEM 110	
	4.6	Questions 121	
5	The s	scanning electron microscope	122
	5.1	How it works 122	
	5.2	Obtaining a signal in the SEM 124	
	5. <b>3</b>	The optics of the SEM 131	
	5.4	The performance of the SEM 133	
	5.5	The ultimate resolution of the SEM 135	
	5.6	Topographic images 141	
	5.7	Compositional images 146	
	5.8	Crystallographic information from the SEM 149	
	5.9	The use of other signals in the SEM 153	
	5.10	Image acquisition, processing and storage 159	
	5.11	The preparation of specimens for examination in the SEM	162
	5.12	Low voltage microscopy 164	
	5.13	Environmental scanning electron microscopy (ESEM) 166	
	5.14	Questions 167	
6	Chem	nical analysis in the electron microscope	169
	6. <i>I</i>	The generation of X-rays within a specimen 170	
	6.2	Detection and counting of X-rays 174	
	6.3	X-ray analysis of bulk specimens 184	
	6.4	X-ray analysis of thin specimens in the TEM 193	
	6.5	Quantitative analysis in an electron microscope 196	
	6.6	Electron energy loss spectroscopy (EELS) 205	
	6.7	A brief comparison of techniques 212	
	6.8	Questions 213	

236

238

243

Contents vii

7.1

7.2

73

7.4

7.5

Answers

Index

Electron microscopy and other techniques

analysis systems 225

Summary 234

Ouestions 234

Further reading

Complementary imaging techniques 214

Complementary diffraction techniques 233

Complementary analysis techniques - alternative